

PATENT

Docket No.: SHIGA-006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 1753

Examiner: Mayekar, K.

RECEIVED

In re Application of: Mamoru Kosakai et al.

OCT 2 8 2003

Serial No. 09/909,075

Filed: July 18, 2001

TC 1700

For: PLASTIC FILM ELECTROSTATIC ADSORPTION APPARATUS AND ELECTROSTATIC ADSORPTION METHOD

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail, in an envelope addressed to Mail Stop Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 10 20 05 Signed Krista Thompson

AMENDMENT

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated July 18, 2003, kindly amend the above-identified application as follows.